Topological Insulator GMR Straintronics for Low-Power Strain Sensors

Lingzhi Li,^{†,||} Yunhua Wang,^{*,‡,§,||} Zongtan Wang,[†] Yulan Liu,[†] and Biao Wang^{*,‡,§}

[†]School of Engineering, Sun Yat-sen University, Guangzhou 510006, China

[‡]Sino-French Institute of Nuclear Engineering and Technology, Sun Yat-sen University, Zhuhai 519082, China

[§]State Key Laboratory of Optoelectronic Materials and Technologies, Sun Yat-sen University, Guangzhou 510275, China

ABSTRACT: A quantum spin Hall insulator, i.e., topological insulator (TI), is a natural candidate for low-power electronics and spintronics because of its intrinsic dissipationless feature. Recent density functional theory and scanning tunneling spectroscopy experiments show that the mechanical strain allows dynamic, continuous, and reversible modulations of the topological surface states within the topological phase and hence opens prospects for TI straintronics. Here, we combine the mechanical strain and the giant magnetoresistance (GMR) of a ferromagnet-TI (FM-TI) junction to construct a novel TI GMR straintronics device. Such a FM-strained-FM-TI



junction permits several energy spectral ranges for 100% GMR and a robust strain-controllable magnetic switch. Beyond the 100% GMR energy range, we observe a strain-modulated oscillating GMR, which is an alternative hallmark of the Fabry-Pérot quantum interference of Dirac surface states. These strain-sensitive GMR responses indicate that FM-strained-FM-TI junctions are very favorable for practical applications for low-power nanoscale strain sensors.

KEYWORDS: topological insulator, giant magnetoresistance, magnetic switch, strain sensor, Fabry-Pérot quantum resonances

1. INTRODUCTION

A three-dimensional (3D) topological insulator (TI) belongs to a new quantum state of matter characterized by the nontrivial Z_2 -order parameter with an insulating bulk state and the protected metallic surface states.¹⁻⁵ One of the most exotic features for TI is that the combination of strong spin-orbit coupling and time-reversal symmetry allows the spinmomentum locked helical surface Dirac fermions, which are responsible for many exotic physical properties of TI. The striking second generation of TI, including Bi₂Se₃, Bi₂Te₃, and Sb₂Te₃, provides an ideal platform for the research of fundamental topological phenomena at room temperature⁶⁻⁹ because of its high purity and simple surface band structure, i.e., large bulk band gap and single Dirac cone, which are confirmed by angle-resolved photoemission spectroscopy and scanning tunneling microscopy.

The interaction between magnetism and surface states of TI has attracted considerable attention for the fundamental interests including the topological magnetoelectric effect,^{10–12} quantized anomalous Hall effect,^{13–15} massive Dirac fermion,¹⁶ geometrical phase,¹⁷ and chiral edge currents,¹⁸ where the ferromagnetism is spontaneous in a magnetically doped TI. In addition, experiments demonstrate that the external magnetic proximity effect can also enable a remarkable ferromagnetic exchange field on the surface of TI at ambient temperature.^{19,20} In this regard, both the ballistic and diffusive magnetotransports (especially, tunneling and giant magnetoresistance (GMR) effects) in various ferromagnet (FM)/TI junctions

have been highly investigated,²¹⁻³⁷ for the potential applications in information processing and storage. Recent works on the controllability of magnetoresistance through a FM/TI junction concern gate voltage,²¹⁻²⁷ magnetization direction,²⁸⁻³⁰ superlattice effects,³¹ magnetic field magnitude,³² domain-wall modulation,³³ and impurity scatterings.³

A mechanical strain can induce the topological phase transition between a common insulator or semimetal and TI (e.g., $Bi_2Se_3^{,38,39}$ Sb₂Se₃^{,39-41} InSb,⁴² Li₂IrO₃^{,43} TiTe₂^{,44} BiTeI,⁴⁵⁻⁴⁷ trigonal tellurium,⁴⁸ HgTe,⁴⁹ HgSe,⁵⁰ KNa₂Bi,⁵¹ NaBaBi,⁵² and Na₃Bi).⁵³ Therefore, a strain offers an alternative way to realize TI. A strain can also tune the surface electronic structure and electronic transports of both 3D TI and topological crystalline insulator (TCI) with keeping the topological phases.^{38,39,54-63} For 3D TCI, the lattice mismatch induces strain, which shifts the Dirac points in the surface Brillouin zone like an effective magnetic vector potential.^{59,60} For 3D TI, a typical hydrostatic pressure allows a uniaxial compressive strain, which makes a monotonic downshift of the Dirac points with respect to energy like a negative electrostatic potential.^{38,39,55-57} Compared with doping, the mechanical strain permits dynamic, continuous, and reversible modulations. Therefore, strain modulation is favorable for practical applications. Herein, we report the GMR response to strain in

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a FM-strained-FM-TI junction (see Figure 1). On the basis of the energy spectrum analysis of propagating states, we



Figure 1. Setup for topological insulator GMR straintronics. The device consists of a FM-strained-FM junction on the top surface of 3D TI (layered Bi_2Se_3). In the left (I) and right (III) FM regions, the longitudinal magnetizations can be parallel (P) or antiparallel (AP) to the applied *x*-directional bias for GMR. In the middle (II) region with width *d*, the top gate supplies a voltage U_g and transfers a uniform hydrostatic pressure to the TI. The inset shows the top view of the top x-y surface of TI.

obtain several types of energy spectral ranges for 100% GMR. By virtue of the magnetotransport calculations, we find a strain-controllable magnetic switch effect with a conversion between an insulating state with no GMR signal and a conducting state with 100% GMR response. We also find that a strain-modulated Fabry-Pérot resonance renders a remarkable oscillating GMR effect in the FM–TI nanostructure. These results show that the TI GMR straintronics is suitable for lowpower nanoscale strain sensors.

2. THEORY

We consider a FM-strained-FM junction on the top surface of a 3D TI (layered Bi_2Se_3), as shown in Figure 1, where a bias is applied in the x direction, a top gate in the middle region (II) with the width d supplies a voltage U_g and transfers a uniform hydrostatic pressure to the TI, and the planar magnetizations denoted by the white arrows in the left region (I) and right region (III) are parallel (P) or antiparallel (AP) to the applied bias. In this work, we focus on the magnetotransport response to the longitudinal ferromagnetic exchange field.³⁵ To capture the main physical picture, it is usually assumed that the proximity-effect-induced ferromagnetism region has a step boundary.^{22–24,26–29,37} Therefore, we write the ferromagnetic exchange field profile as $\vec{M}(x) = M_x[\Theta(-x) + \eta\Theta(x-d)]\vec{e}_x$ where $\Theta(x)$ is the Heaviside step function and η is 1 and -1for P and AP configurations, respectively. Similarly, the potential profile of the junction is approximately expressed by $V(x) = (U_g - U_s)\Theta(x)\Theta(d - x)$, with the gate voltage (U_g) and the strain-induced negative potential $(-U_s)$. In this regard, the effective low-energy Hamiltonian of the surface states for the system under consideration reads

$$\hat{H} = \nu_{\rm F}(\vec{\sigma} \times \vec{k}) \cdot \vec{e}_z + \vec{\sigma} \cdot \vec{M}(x) + V(x)\sigma_0 \tag{1}$$

where $v_{\rm F} = 4.08$ eV Å is the Fermi velocity of the surface states for Bi₂Se₃, $\vec{\sigma}$ is the vector of Pauli spin matrices, \vec{k} is the electron momentum, and σ_0 is the 2 × 2 identity matrix. Considering the *y*-direction momentum conservation, we write the wave functions in the region *j* (*j* = I, II, and III) along the $\pm x$ directions as $\psi_j^{\pm}(x,y) = \psi_j^{\pm}(x)e^{ik_j y}$, where $\psi_j^{\pm}(x)$ is obtained from eq 1 and takes the form as

$$\psi_{j}^{\pm}(x) = e^{\pm ik_{x,j}x} \left(\frac{1}{\frac{\nu_{F}k_{y,j} \mp i\nu_{F}k_{x,j}}{E - V(x)}} \right)$$
(2)

For the three regions, we have $k_{y,I} = M_x/v_F + k_y$, $k_{x,I} = \operatorname{sgn}(E)(E^2/v_F^2 - k_{y,I}^2)^{1/2}$, $k_{x,II} = \operatorname{sgn}(E - V)((E - V)^2/v_F^2 - k_y^2)^{1/2}$, $k_{y,II} = k_y$, $k_{x,III} = \operatorname{sgn}(E)(E^2/v_F^2 - k_{y,III}^2)^{1/2}$, and $k_{y,III} = \eta M_x/v_F + k_y$. The incident angle is defined by $\theta = \arcsin(v_Fk_{y,I}/E)$, and the group velocities in the three regions take the forms as $v_{x,I} = v_F^2 k_{x,I}/E$, $v_{x,III} = v_F^2 k_{x,II}/(E - V)$, and $v_{x,III} = v_F^2 k_{x,III}/E$, respectively. To guarantee the current conservation with a normalized incident probability density, we write the total wave functions in the three regions as

$$\begin{cases} \psi_{\rm I}(x) = (\psi_{\rm I}^+(x) + r\psi_{\rm I}^-(x))/\sqrt{2|v_{x,{\rm I}}|} \\ \psi_{\rm II}(x) = (a\psi_{\rm II}^+(x) + b\psi_{\rm II}^-(x))/\sqrt{2|v_{x,{\rm II}}|} \\ \psi_{\rm III}(x) = t\psi_{\rm I}^+(x)/\sqrt{2|v_{x,{\rm III}}|} \end{cases}$$
(3)

where *r* is the reflection coefficient, *t* is the transmission coefficient, and *a* and *b* are the unknown complex coefficients. Using the continuity of two-component wave functions in real spin space at the left (x = 0) and right (x = d) boundaries, we can obtain the corresponding transmission probability for P ($\eta = 1$) and AP ($\eta = -1$) configurations, as follows

$$T_{\eta}(E, V, M_{x}, k_{y}) = \frac{k_{x,\Pi}}{k_{x,\Pi}} \left| \frac{(\alpha - \alpha^{*})(\beta - \beta^{*})}{e^{ik_{x,\Pi}d}(\beta^{*} - \alpha^{*})(\beta - \gamma_{\eta}) - e^{-ik_{x,\Pi}d}(\beta - \alpha^{*})(\beta^{*} - \gamma_{\eta})} \right|^{2}$$
(4)

where the upper index asterisk denotes the complex conjugate, $\alpha = (v_F k_{y,I} - iv_F k_{x,I})/E$, $\beta = (v_F k_y - iv_F k_{x,II})/(E - V)$, and $\gamma_{\eta} = (\eta M_x + v_F k_y - iv_F k_{x,III})/E$. We focus on the ballistic transport system with few impurities. For this case, the conductance for a small bias at finite temperature reads

$$G_{\eta}(E, V, M_x) = G_0 \int dE \int T_{\eta}(E, V, M_x, k_y) \frac{-\partial f}{\partial E} dk_y$$
(5)

where $G_0 = e^2 L_y / \pi h$ is the conductance unit with the *y*-direction width $L_y = 400$ nm and $f(E) = 1/(e^{(E-E_F)/k_BT} + 1)$ is the Fermi–Dirac distribution function. If a very low temperature is considered, the above formula is further written as

$$G_{\eta}(E_{\rm F}, V, M_{x}) = G_{0} \int T_{\eta}(E_{\rm F}, V, M_{x}, k_{y}) \, \mathrm{d}k_{y} \tag{6}$$

Then, the GMR is defined as

$$GMR = (1 - G_{AP}/G_P) \times 100\%$$
 (7)

3. RESULTS AND DISCUSSION

3.1. Energy Spectral Range for Strain-Dependent 100% GMR. Before we discuss the strain-dependent energy spectra, let us comment on the strain effects on the Dirac



Figure 2. Energy spectra of propagating states through the FM-strained-FM-TI junction in the (k_y, E) space. Type A with $M_x = 50$ meV, $U_s = 60$ meV, and $U_g = 0$ meV for (a) P and (b) AP configurations. Type B with $M_x = 50$ meV, $U_s = 10$ meV, and $U_g = 0$ meV for (c) P and (d) AP configurations. Type C with $M_x = 50$ meV, $U_s = 10$ meV, and $U_g = 100$ meV for (e) P and (f) AP configurations. The overlapped yellow areas by the energy spectra of all of the three regions, i.e., I + II + III, allow the propagating waves across the entire junction.





Figure 3. Contour plots of transmission probability through the FM-strained-FM-TI junction as a function of k_y and E for (a) P and (b) AP configurations of type A, (c) P and (d) AP configurations of type B, and (e) P and (f) AP configurations of type C, with the same corresponding parameters as in Figure 2. Conductance G_P and G_{AP} and GMR as a function of energy E_F for (g) type A, (h) type B, and (i) type C. For all cases, d = 100 nm.

surface states of Bi₂Se₃. According to the first-principles calculations,^{38,55,56} it can be summarized that the topological insulating phase for layered Bi₂Se₃ remains if the strain is less than 6.4%³⁸ and that the negative electrostatic potential $(-U_s)$ induced by the compressive uniaxial strain can be roughly approximated as two linear piecewise functions of strain: For 0 < $\varepsilon \leq 3\%$, $U_s = 2\varepsilon$, and for 3% < $\varepsilon \leq 6.4\%$, $U_s = 3.5\varepsilon - 0.045$, in units of eV.⁵⁵ If a compressive strain larger than 6.4% is applied, the bulk gap will be closed, and the phase transition

for layered Bi₂Se₃ from TI to a common insulator happens. Consequently, the Dirac bands are broken by the large strain.⁵⁶ Therefore, in this work, the applied strain is limited to 6.4% and U_s is correspondingly less than 0.179 eV.

Now we begin to perform energy spectrum analysis. The definition of GMR in eq 7 shows that the positive 100% GMR occurs if there exists an energy spectral range with $G_{AP} = 0$ and $G_P \neq 0$. In general, both the propagating and nonpropagating (evanescent) states in middle region II contribute to the

conductance. However, the tunneling of evanescent surface Dirac states in region II rapidly vanishes with the increase of the width d_i as demonstrated in eq 4. Thus, if a relatively large width d is adopted in region II, the contribution to conductance by evanescent mode is well negligible. Then, we can approximately use the energy spectra of propagating states to determine the energy range of 100% GMR. Figure 2 shows the energy spectra of propagating states in the (k_{u}, E) space for both P and AP configurations of the FM-strained-FM-TI junction. As we can see, in the (k_{ν}, E) space, the in-plane magnetic exchange field M_x shifts the original Dirac point (0, 0) to the new position $(-M_x/v_{\rm F}, 0)$ in magnetic regions I and III for P configuration, but for AP configuration, the exchange field shifts the original Dirac point (0, 0) to $(M_x/\nu_{\rm F}, 0)$ in region III. The total potential V involving the gate voltage U_{o} and the compressive-strain-induced negative potential $(-U_s)$ moves down or up the Dirac cone in middle region II. Therefore, to determine the GMR energy spectral range, we should further make clear the interplay among M_x , U_g , and U_s . By comparing the sizes between V and M_x and taking the range of k_{y} into account, we classify the GMR energy spectral range into three types, as demonstrated in Table 1.

For type A in Figure 2a,b, $V < -M_x$, $G_P \neq 0$ for the positive energy, $G_{AP} = 0$ for $0 \le E \le M_x$ and hence the energy range for the 100% GMR is from 0 to M_x . For type B, as shown in Figure 2c,d, $-M_x \le V \le M_x$, $G_P = 0$ for $0 \le E \le (V + M_x)/2$, $G_{AP} = 0$ for $0 \le E \le M_x$, and $G_P \neq 0$ for $E > (V + M_x)/2$. Therefore, the energy range of the 100% GMR for type B is from $(V + M_x)/2$ to M_x . For type C in Figure 2e,f, $V > M_x$, $G_P \neq 0$ for the positive energy, $G_{AP} = 0$ for $0 \le E \le M_x$ and hence the energy range for the perfect GMR is from 0 to M_x . We note that there exists a forbidden energy range for both P and AP configurations in type B and the energy ranges for the 100% GMR in both types A and C are consistent, but the ranges of k_y are different, as demonstrated in Table 1.

To demonstrate the 100% GMR energy range determined by the energy spectrum analysis of propagating states and the features of the three types, we further numerically calculate the transmission (Figure 3a-f), conductance, and GMR (Figure 3g-i), where the width d is taken as 100 nm such that the contribution of conductance is almost entirely attributed to the propagating states. As predicted above, the transmission energy and angle ranges of the propagating states, the zero and nonzero conductance areas, and the 100% GMR energy range agree well with the energy spectrum analysis. Beyond the perfect GMR energy range, the oscillating GMR related to the transmission resonance occurs, and it will be studied later. Since the three types depend on the relation among M_x , U_g , and U_s , the three types with the 100% GMR can be tuned by strain if U_g and M_x are fixed. Although the compressive strain acts as a negative potential, the strain-sensing effect rather than a negative voltage is necessary for a TI strain sensor. For type B, we also indeed observe a forbidden energy range for both P and AP configurations, where the GMR does not exist. The cutoff value between the forbidden and 100% GMR energy ranges is determined by $(U_g - U_s + M_x)/2$. Such a sharp strain-modulated GMR response from no GMR signal to 100% GMR is very suitable for strain (pressure) sensors and straincontrollable magnetic switches.

3.2. Strain-Controllable Magnetic Switch. As figured out above, for type B, the applied strain can change the zero-conductance cutoff value for the P configuration, but the zero-conductance cutoff value for the AP case is unchangeable by

strain, as shown in Figure 3h. This property motivates us to construct a novel strain-controllable magnetic switch. To illustrate the features of the magnetic switch, we define two states: the insulating state with no GMR (ISNG) and the switched state with perfect GMR (SSPG). The conductance as a function of strain is presented in Figure 4, where the light



Figure 4. Conductance G_P and G_{AP} as a function of strain-induced potential U_{s^*} (a) $M_x = 50$ meV, $U_g = 40$ meV; (b) $M_x = 40$ meV, $U_g = 70$ meV. For all cases, $E_F = 25$ meV and d = 100 nm. The state ISNG is represented by the light green areas, and the state SSPG is represented by the light yellow areas. The strain-controllable magnetic switch has a single cutoff value in (a) for the conversion ISNG \rightarrow SSPG and double strain cutoff values in (b) for the conversion SSPG \rightarrow ISNG \rightarrow SSPG.

green and yellow backgrounds denote the strain ranges for ISNG and SSPG, respectively. Using the cutoff value $E = (U_g - U_s + M_x)/2$ for type B, we obtain the cutoff strain from ISNG to SSPG

$$U_{\rm s}(\rm ISNG \rightarrow \rm SSPG) = U_{\rm g} + M_x - 2E$$
 (8)

From Figure 4a, we can observe the magnetic switch with only single strain cutoff value $U_s(\text{ISNG} \rightarrow \text{SSPG})$ and its converting route ISNG \rightarrow SSPG with increasing the strain. If a larger U_g is given by the top gate with $U_g > M_{xy}$ the GMR energy range belongs to type C for a small strain. However, with the enhanced strain, the GMR energy range is changed from type C to B. Therefore, one can also realize a magnetic switch with double strain cutoff values. The other cutoff value is given by

$$U_{\rm s}({\rm SSPG} \rightarrow {\rm ISNG}) = U_{\rm g} - M_x$$
 (9)

From Figure 4b, we can see the strain-controllable GMR switch with double cutoff values and its converting route SSPG \rightarrow ISNG \rightarrow SSPG. In an actual system, thermal fluctuations and contact resistance may slightly reduce the switch effect.⁵⁴ However, the large energy intervals and accessible value of $G_{\rm p}$ make the strain-manipulated magnetic switch practical in experiments.

3.3. Strain-Modulated Fabry-Pérot Resonance and Oscillating GMR. Because of the Dirac linear dispersion for the surface states, the unique Fabry-Pérot quantum interference of the surface states has attracted considerable attention in both fundamental interest and practical applications in TI.⁶⁴⁻⁶⁹ For the considered FM-strained-FM-TI junction,



Figure 5. Contour plots of transmission probability through the FM-strained-FM-TI junction as a function of θ and U_s . $E_F = 80$ meV for (a) P and (b) AP configurations. $E_F = 70$ meV for (c) P and (d) AP configurations. $E_F = 60$ meV for (e) P and (f) AP configurations. Conductance G_P and G_{AP} and GMR as a function of U_s for (g) $E_F = 80$ meV; (h) $E_F = 70$ meV; and (i) $E_F = 60$ meV. For all cases, $M_x = 50$ meV, $U_g = 0$ meV, and d = 100 nm.

the magnetic confinements of exchange fields in the left and right regions serve as two barriers and the strain-induced negative potential in the middle region acts as a well. Therefore, this strained FM–TI junction is a natural resonant cavity and hence the Fabry-Pérot resonance should happen.

We numerically calculate the transmission probability as a function of the strain-induced potential U_s and the incident angle θ for both P and AP configurations, as demonstrated in Figure 5a-f, where we have chosen the values of E_F beyond the 100% GMR energy range. A remarkable strain-modulated Fabry-Pérot resonance occurs, but the transmission angle ranges for P and AP configurations are quite different because of the different magnetic confinements for different combinations.

However, an observation of the angle-dependent transmission resonance is challenging in experiments. We argue that GMR can be used to probe the Fabry-Pérot resonance in experiments because GMR is essentially determined by the conductance, which is related to the angular average of the transmission probability. Therefore, we further calculate the conductance and GMR as a function of the strain-induced potential for both P and AP configurations. As shown in Figure 5g–i, the conductance and GMR oscillate with the increasing strain, as a result of the Fabry-Pérot resonance. In addition, the oscillating GMR peaks and valleys are corresponding to the peaks of $G_{\rm P}$ and $G_{\rm AP}$, respectively. Therefore, the oscillating GMR offers an alternative hallmark of the strain-modulated Fabry-Pérot interference for TI surface states.

4. CONCLUSIONS

In conclusion, we have investigated the strain effect on GMR in a FM-strained-FM-TI junction. The energy spectrum analysis of propagating states for this junction indicates that the spectral distribution of 100% GMR involves three types as a result of the interplay among the magnetic exchange field, the gate voltage, and the strain-induced potential. The magnetotransport calculations, including the transmission, conductance, and GMR, not only confirm the energy spectrum analysis but also predict a novel strain-controllable magnetic switch, where the applied strain with single or double cutoff values can switch between an insulating state with no GMR signal and a conducting state with 100% GMR. Beyond the energy range of the 100% GMR, the strain-modulated GMR displays a periodic oscillation and the oscillating peaks and valleys are corresponding to the Fabry-Pérot resonances for P and AP configurations. Therefore, via an experimental measurement of the strain-modulated oscillating GMR, one can probe the Fabry-Pérot quantum interference of the Dirac surface states. These strain-controllable GMR responses indicate that the proposed TI GMR straintronics is quite practical for low-power nanoscale strain sensors.

AUTHOR INFORMATION

Corresponding Authors

- *E-mail: wangyh49@mail.sysu.edu.cn (Y.W.).
- *E-mail: wangbiao@mail.sysu.edu.cn (B.W.).

ORCID [®]

Yunhua Wang: 0000-0002-0436-6750

Author Contributions

^{II}L.L. and Y.W. contributed equally to this work.

Notes

The authors declare no competing financial interest.

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